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addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA
22313-1450, on the date shown below.

Dated: 2/2/09

Signature: Eileen Sheffield
(Eileen Sheffield)

Docket No.: RPP-202 (10510421)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
BECKMANN

Application No.: 10/552,677

Group Art Unit: 1792

Filed: November 21, 2005

Examiner: N. K. Ford

For: HIGH FREQUENCY PLASMA JET SOURCE
AND METHOD FOR IRRADIATING A
SURFACE

AMENDMENT UNDER RULE 111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Responsive to the office action mailed August 5, 2008, please grant the accompanying
petition for a three month extension of time and amend the application as follows: